J1046 U.S. PTO 09/898439 07/05/01

Class	Subclass	ISSUE CLASSIFICATION

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PATENT NUMBER 1

U.S. UTILITY Patent Application

O.I.P.E.	PATENT DATE
SCANNED NS4 Q.A. Ed	

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/898439		438	643	2818	D. HOANG

APPLICANTS: Tue Nguyen
Tai Nguyen

TITLE: Plasma semiconductor processing system and method

PTO-2040 12/99

ISSUING CLASSIFICATION

ORIGINAL CLASS	ORIGINAL SUBCLASS	CROSS REFERENCE(S) CLASS	CROSS REFERENCE(S) SUBCLASS (ONE SUBCLASS PER BLOCK)

INTERNATIONAL CLASSIFICATION

☐ Continued on Issue Slip Inside File Jacket

☐ TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.

☐ The term of this patent subsequent to _____ (date) has been disclaimed.

☐ The term of this patent shall not extend beyond the expiration date of U.S Patent. No. _____

☐ The terminal ____ months of this patent have been disclaimed.

_____ (Assistant Examiner) _____ (Date)

_____ (Primary Examiner) _____ (Date)

_____ (Legal Instruments Examiner) _____ (Date)

NOTICE OF ALLOWANCE MAILED

ISSUE FEE

Amount Due	Date Paid

ISSUE BATCH NUMBER

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